

Title (en)

Gas supply system, valve assembly and method of forming reactant pulses by operating a valve assembly

Title (de)

Gaszufuhrvorrichtung, Ventilanordnung und Verfahren zur Erzeugung von Reaktantpulsen mit einer Ventilanordnung

Title (fr)

Système d'alimentation en gaz, ensemble de soupapes et procédé de formation de pulsations du réactant en utilisant un ensemble de soupapes

Publication

**EP 1486707 B1 20071121 (EN)**

Application

**EP 03076812 A 20030611**

Priority

EP 03076812 A 20030611

Abstract (en)

[origin: EP1486707A1] A gas supply system for pulse-wise feeding a reactant gas to a reactor, the gas supply system comprising: a first valve (300) being a four-port diaphragm valve; a second valve (500) which in an open state brings the first port (30) into fluid communication with an exhaust and in a closed state closes off said fluid communication; wherein the gas supply system provides a reactant flow state in which the first valve (300) is in an open state and the second valve (500) is in a closed state, and wherein the gas supply system provides a purge state in which the first valve (300) is closed and the second valve (500) is in an open state. Also disclosed are a method of switching a process fluid by operating a gas supply system according to the invention and a valve assembly for use in such a gas supply system.

IPC 8 full level

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